

**Search Notes**

Application/Control No.

10/824,401

Examiner

Arpan P. Savla

Applicant(s)/Patent under  
Reexamination

KIM, DU-YEUL

Art Unit

2185

**SEARCHED**

Class	Subclass	Date	Examiner

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Updated East text search	9/18/2006	A.S.
Consulted Brian Peugh for rejection help	9/20/2006	A.S.
Consulted SPE Reginald Bragdon for rejection help	9/20/2006	A.S.
Consulted SPE Nasser Moazzami for search help	9/21/2006	A.S.